



PATENT AND TRADEMARK OFFICE
INFORMATION DISCLOSURE CITATION
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Sheet 1 of 1

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| ATTORNEY DOCKET NO. | SERIAL NO. |
| 5077-000032 | 09/835,964 |
| APPLICANT | |
| Satoshi Matsuura et al. | |
| FILING DATE | GROUP |
| April 16, 2001 | |

| U.S. PATENT DOCUMENTS | | | | | | |
|-----------------------|---------------------|-----------------|------|------|-----------------|------------------------------|
| Ref. Desig. | Examiner's Initials | Document Number | Date | Name | Class/ Subclass | (If appropriate) Filing Date |
| 1. | | | | | | |

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Examiner: Satoharu Saitoh Date Considered: 6/5/05

EXAMINER: Please initial if citation considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



FORM HDP-1449 (Based on Form PTO-1449)

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Sheet 1 of 2

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| April 16, 2001 | 2622 |

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| 2. | SFS | CN Office Action of February 20, 2004 for the corresponding Chinese patent application CN 01110721.9 |

Examiner: Satoshi SFS Date Considered: 6/5/05

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PTO-1449 HDP-1449 (Based on Form PTO-1449)

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| 1. | SPS | State Intellectual Property Office of People's Republic of China; Second Office Action for Application No. 01110721.9; Issued September 17, 2004. |

* Chinese Patent App. No. 1196855 A corresponds to International Patent App. No. WO 97/50243.

Examiner:

Satoshi Matsuura

Date Considered:

6/5/05

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